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Frequency Dependence of Displacement Current and Channel Current in Pentacene Thin-Film Transistors

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1. Introduction

Organic thin-film transistors (OTFTs) which use organic semiconductor as active layer have attracted considerable attentions for their potentials such as low-cost, large-area, and flexible devices as well as the mobility, which is comparable to that of hydrogenated amorphous silicon (a-Si:H) TFTs.[1] For the practical use of OTFTs such as RFID or logic circuit, it is important to evaluate carrier injection properties under high frequency operation. Displacement current measurement (DCM) is a direct method to probe the carrier injection properties in organic materials.[2-5]

We have developed simultaneous measurements system of displacement current and channel current in top-contact OTFTs, which expands DCM to three terminal devices, and which enables us to understand carrier injection properties under the device operation.[6]

In this paper, we demonstrate the frequency dependence of displacement current and channel current in top-contact pentacene thin-film transistors. The frequency dependence of field-effect mobility, threshold voltage and carrier injection voltage at the source electrode are evaluated at frequencies ranging from 1 to 50 kHz.

2. Experiments

The detailed description of the simultaneous measurements of displacement current and channel current has been provided in our previous paper[6]: however, only a brief outline is provided here. Figure 1 shows a schematic diagram of the simultaneous measurements system of displacement current (I_{dis}) and channel current (I_{DS}). I_{dis} and I_{DS} are evaluated from source (I_S) and drain (I_D) currents under the applications of a triangular-wave of gate voltage (V_{GS}) and a constant drain voltage (V_{DS}). Displacement current at source (I_{disS}) and drain electrode (I_{disD}) is given by

$$I_{disS,disD} = C_{S,D}(t) \frac{dV_{GS}}{dt}, \quad (1)$$

where $C_{S,D}(t)$ consist of capacitances of organic thin-film layer (C_1) and that of gate dielectric layer (C_2) under the source and drain electrode, respectively. In the case of the simultaneous measurements system of I_{dis} and I_{DS} in the OTFT structure, I_{dis} and I_{DS} are expressed by measured I_S

and I_D as

$$I_{dis} = I_{disS} + I_{disD} = I_S + I_D,$$

and

$$I_{DS} = \frac{-I_S + I_D}{2}, \quad (2)$$

respectively, when it is assumed that I_{disS} is the same as I_{disD} . By using these equations, I_{dis} and I_{DS} can be evaluated from the simultaneously measured I_S and I_D .

We use top-contact pentacene OTFTs with SiO₂/polyimide dual-gate dielectric and gold electrodes in the experiments. The structure and fabrication procedures of the top-contact pentacene OTFTs have been described in our previous papers.[6,7]

The pentacene OTFTs were annealed at 400 K in nitrogen atmosphere for several hours before the measurements, and all measurements were conducted in nitrogen atmosphere. I_S and I_D were simultaneously measured using a digitizing storage oscilloscope (Hioki, 8855) under the applications of a constant drain voltage (V_{DS}) and a triangular-wave gate voltage (V_{GS}) in the top-contact pentacene OTFTs. V_{GS} was applied as five cycles of triangular-waves with the amplitude of 30 V_{p-p} at frequencies ranging from 1 to 50 kHz. During all the measurements, V_{DS} was maintained at -14 V. The measurements were performed at 300 K.

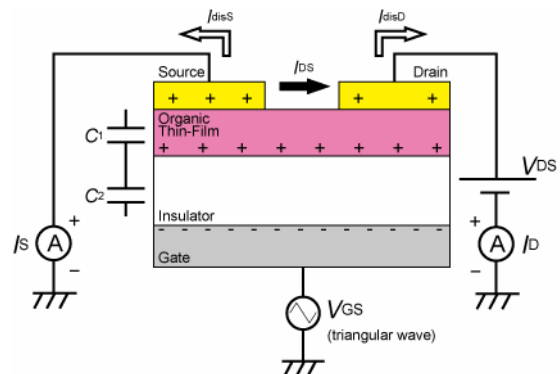


Fig. 1 Schematic diagram of simultaneous measurements system of I_{DS} and I_{dis} in top-contact OTFTs. I_S and I_D are simultaneously measured under the application of a triangular-wave V_{GS} and a constant V_{DS} . C_1 and C_2 are the capacitance of the gate insulator layer and that of organic thin-film layer, respectively.

3. Results and Discussions

Figure 2 shows the typical experimental results of (a) square-root of channel current ($I_{DS}^{1/2}$) – V_{GS} and (b) normalized displacement current by frequency (I_{dis}/f) – V_{GS} characteristics at the frequencies of 1 and 50 kHz. I_{dis} and I_{DS} were calculated from the simultaneously measured I_S and I_D of the first cycle of V_{GS} using eq. (2). In Fig. 2 (a), $I_{DS}^{1/2}$ – V_{GS} characteristics obtained by a semiconductor parameter analyzer (Agilent, 4156C) is also plotted.

From Fig. 2 (a), the field-effect mobility (μ) and the threshold voltage (V_{th}) were evaluated as 0.31 and 0.30 cm^2/Vs , and 3.7 and 4.0 V at 1 and 50 kHz, respectively. μ and V_{th} obtained by the semiconductor parameter analyzer were 0.31 cm^2/Vs and 3.3 V, respectively, which were in good agreement with those obtained by the simultaneous measurements. It notes that μ and V_{th} at other frequencies between 1 and 50 kHz (not shown) were also identical. In Fig. 2 (b), the voltage where the displacement current at the source electrode starts to increase was defined as carrier injection voltage at the source electrode (V_{inj}), since pentacene thin-film acts as p-type semiconductor, carrier should be injected to pentacene thin-film/gate insulator interface below V_{inj} . [6] V_{inj} were estimated as 12 and 11 V at 1 and 50 kHz, respectively.

From the comparison between the results at the gate voltage frequency of 1 and 50 kHz, μ , V_{th} and V_{inj} were identical at each frequency, which indicates that the both carrier injection and carrier transport in top-contact pentacene OTFTs can fully operate at 50 kHz. It notes that in Fig. 2 (a), the reason why there were peaks at $0 < V_{GS} < V_{inj}$ at 1 and 50 kHz is that I_{disS} was not equal to I_{disD} in this V_{GS} range. According to eq. (1), displacement current is proportional to the gate voltage frequency, the peak at 50 kHz was seven times larger than that at 1 kHz due to the carrier injection at the source electrode.

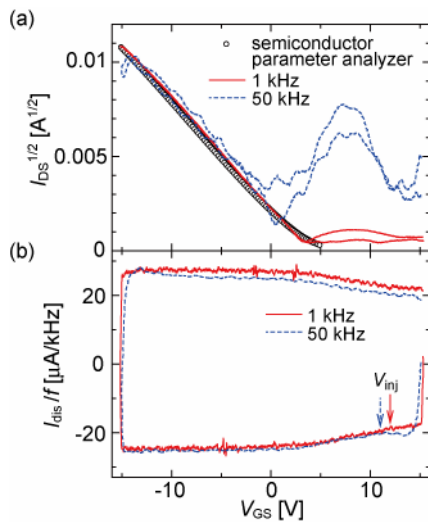


Fig. 2 Experimental (a) $I_{DS}^{1/2}$ – V_{GS} and (b) I_{dis} – V_{GS} characteristics at gate voltage frequency of 1 and 50 kHz. $I_{DS}^{1/2}$ – V_{GS} characteristics obtained by semiconductor parameter analyzer is also shown.

4. Conclusions

Carrier injection and carrier transport properties, such as field-effect mobility, threshold voltage, and carrier injection voltage at the source electrode were evaluated by the simultaneous measurements system of displacement current and channel current in top-contact pentacene OTFT. The simultaneous measurements system of I_{dis} and I_{DS} can be applied at the gate voltage frequency of 50 kHz in the top-contact pentacene OTFTs, and both carrier injection and carrier transport properties were independent of the frequency.

For the practical use of organic thin-film transistors, simultaneous measurements system of I_{dis} and I_{DS} is a simple and powerful technique to evaluate carrier injection properties and carrier transport properties under the high frequency device operation.

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